

Customer No. 22,852
Attorney Docket No. 04329.3253

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinya TAKYU *et al.*)
Application No.: 10/787,207) Group Art Unit: 2812
Filed: February 27, 2004) Examiner: Not Assigned
For: SEMICONDUCTOR WAFER)
DIVIDING METHOD AND)
APPARATUS)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

The following are listed on the accompanying PTO-1449 and are in a non-English language:

1. Japanese Patent Application No. 61-112345. The relevance of this document is discussed at pages 3 and 4 of the specification of the present application.

2. Japanese Patent Application No. 2001-144037. The relevance of this document is discussed at pages 4 and 5 of the specification of the present application.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 14, 2004

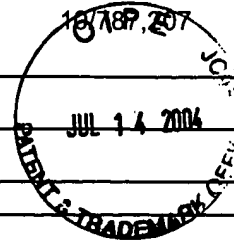
By: 

Richard M. Burgujian
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Enclosures
RVB/FPD/sem

INFORMATION DISCLOSURE CITATION

Atty. Docket No. 04329.3253	Application No.
Applicant Shinya TAKYU <i>et al.</i>	
Filing Date February 27, 2004	Group: 2812



U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	6,590,181 B2	7/8/03	Choo et al.			
	6,407,360 B1	6/18/02	Choo et al.			
	6,562,698 B2	5/13/03	Manor			
	6,465,330 B1	10/15/02	Takahashi et al.			
	6,184,109 B1	2/6/01	Sasaki et al.			
	5,888,883	3/30/99	Sasaki et al.			
	6,337,258 B1	1/8/02	Nakayoshi et al.			
	6,294,439 B1	9/25/01	Sasaki et al.			
	6,756,562 B1	6/29/04	Kurosawa et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
61-112345	5/30/86	Japan			No
2001-144037	5/25/01	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

IIJIMA, T. et al., "SEMICONDUCTOR DEVICE OBTAINED BY DIVIDING SEMICONDUCTOR WAFER BY USE OF LASE DICING TECHNIQUE AND METHOD OF MANUFACTURING THE SAME", Application No. 10/418,274, Filed April 18, 2003

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce